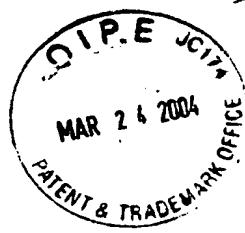


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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): J. TANAKA, et al  
Serial No.: 10/087,982  
Filed: March 5, 2002  
For: DATA PROCESSING APPARATUS FOR SEMICONDUCTOR  
PROCESSING APPARATUS  
Group: 1763  
Examiner: P. Hassanzadeh

**STATEMENT OF SUBSTANCE OF INTERVIEW**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

March 24, 2004

Sir:

Applicants note that an Interview Summary accompanied the Notice of Allowance and confirm that the undersigned attorney conducted a telephone interview with the Examiner, Mr. Hassanzadeh, on March 8 and 12, 2004, during which time amendments to the claims as effected by the Examiner's Amendment accompanying the Notice of Allowance and Interview Summary, were discussed and authorized in order to place the application in condition for allowance. Thus, applicants confirm the substance of the interview as provided by the Interview Summary and although applicants consider the submission of this paper to be unnecessary, to avoid any question concerning the requirements for applicant to file a statement of the substance of the interview, this statement is submitted.

Respectfully submitted,

Melvin Kraus  
Registration No. 22,466  
ANTONELLI, TERRY, STOUT & KRAUS, LLP

MK/cee  
(703) 312-6600